



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hajime YAMAMOTO et al.**

Art Unit: 1795

Application Number: 10/647,247

Examiner: **Daborah Chacko Davis**

Filed: **August 26, 2003**

Confirmation Number: 1773

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE,  
AND METHOD OF FORMING RESIST PATTERN**

Attorney Docket Number: **031029**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Mail Stop: **Amendment**  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 29, 2008

Sir:

This paper is filed in response to the Office Action dated April 1, 2008.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.